



[10191/3939]

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventors : Andrea URBAN et al.  
Serial No. : 10/520,886  
Filed : July 21, 2005  
For : A LAYER SYSTEM COMPRISING A SILICON LAYER  
AND A PASSIVATING LAYER, A METHOD FOR  
PRODUCING A PASSIVATING LAYER ON A SILICON  
LAYER AND THEIR USE  
Examiner : Laura M. Menz  
Art Unit : 2813  
Confirmation No. : 7030

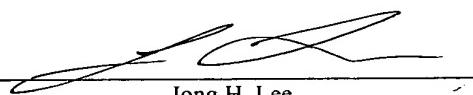
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Commissioner for Patents  
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Signature:



Jong H. Lee

**AMENDMENT ACCOMPANYING RCE**

SIR:

In response to the final Office Action mailed on October 7, 2008, please reconsider the above-identified application based on the following. This Amendment is the required submission accompanying the concurrently-filed RCE. A two-month extension of time for filing a reply is requested in the concurrently-filed RCE.

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.